

Mask-defined abrasive-jet micromachining

Kruusing, Arvi; Leppävuori, Seppo; Uusimäki, Antti; Uusimäki, M. MICRO SYSTEM Technologies 98 : 6th International Conference and Exhibition on Micro Electro, Opto, Mechanical Systems and Components : Potsdam, Germany, December 1-3, 1998 1998 / p. 673-675